Observation of 60 GHz and 20 GHz Multiple Photon-Photon Resonances Using Active Multimode Interferometer Laser Diodes

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Observation of 60 GHz and 20 GHz Multiple Photon-Photon Resonances Using Active Multimode Interferometer Laser Diodes

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Abstract: $1 \times N$ active multimode interferometer laser diodes to achieve two photon-photon resonances (PPRs) have been designed and fabricated. Very high frequency of 60 GHz in addition to 20 GHz PPR peaks were confirmed.

Keywords: Active MMI-LD; Photon-Photon resonance; High speed modulation

1. INTRODUCTION

Optical inter-connection is highly developed due to computer technology advancing [1], and direct modulation laser diode (DML) may be one of the transmitter candidates especially for the future mobile IT-devices which speed is required around 100 Gbps [2, 3], whereas the modulation speed of DML has been limited up to around 50 Gbps. One way to improve the maximum modulation rate beyond 100 Gbps is photon-photon resonance (PPR) [2-7]. In this paper, the design concept and the experimental results of multiple photon-photon resonances based on active-MMI configuration is reported. This scheme of multiple photon-photon resonances enables plural PPR peaks which may achieve higher modulation speed in the future. As a result, two PPR resonance frequencies of around 20 GHz, and 60 GHz have been successfully confirmed experimentally.

2. CONCEPT OF ACTIVE-MMI LDs

![Fig. 1. Schematic view of active-MMI LD](image)

The PPR peak is designed using wavelength differences between center wavelengths of each arm at $N$-side of MMI [8]. As shown in Fig. 1, there are three arms at LHS of the $1 \times N$ active-MMI configuration. In case of $N \geq 3$, the phase must be matched at the MMI edge to avoid non self-image at the RHS of the MMI. This phase-matching requirement causes free spectral range in the transmission spectrum of the $1 \times N$ MMI. To secure this phase-matching condition, bending regions in the both top and bottom arms are introduced. The bending region also induces wavelength dependency which gives the center wavelengths of each arm. Each center wavelength slightly different as indicated in Fig. 1 as to achieve two different PPR peaks in the emission wavelength is designed.

The relation between three different center wavelengths are schematically illustrated in Fig. 2. In the case of center wavelengths arranged as Fig. 1, two different peak shifts are designed. The corresponding wavelength differences are derived in the following equation (1):

$$\Delta \lambda = \lambda_m - \lambda_{center} = \frac{z \Delta \lambda}{n_{eq}} \cdot \frac{1}{2 \phi + 2 \pi m} - \lambda_{center} \quad (1)$$

Here, $\lambda_{center}$: the center wavelength, which is given by the transmittance peak wavelength of the MMI waveguide, $\Delta \lambda$: Path length difference between center and bending waveguide, $n_{eq}$: equivalent refractive index of waveguide, $\lambda_m$: wavelength, $m$: positive integer, and $\phi$: initial phase for $1 \times N$ MMI waveguide (For instance in case of $1 \times 3$ MMI shown in Fig. 1, $\phi = 1/3\pi$). From eq. (1), $\Delta L$ is derived as eq. (2):

$$\Delta L = \frac{n_{eq}}{2} \cdot (\lambda_{center} + \Delta \lambda) \cdot (2 \phi + 2 \pi m) \quad (2)$$

And according to the eq. (2), to obtain two different PPR peaks are designed as summarized in Table 1. PPR frequency $F_{PPR}$ corresponded according to the following eq. (3):

$$F_{PPR} = \frac{\Delta \lambda c}{2 \pi} \quad (3)$$

![Fig. 2. Schematic concept of PPRs using $1 \times N$ active-MMI](image)

Table 1. The PPR designs in this work

<table>
<thead>
<tr>
<th>$\lambda_{center}$ [nm]</th>
<th>$\Delta L$ [mm]</th>
<th>$\Delta \lambda$ [nm]</th>
<th>$F_{PPR}$ [GHz]</th>
</tr>
</thead>
<tbody>
<tr>
<td>1550.00</td>
<td>-</td>
<td>-</td>
<td>-</td>
</tr>
<tr>
<td>1550.30</td>
<td>0.02</td>
<td>0.30</td>
<td>35</td>
</tr>
<tr>
<td>1550.75</td>
<td>0.04</td>
<td>0.75</td>
<td>80</td>
</tr>
</tbody>
</table>

As shown in Tab.1, PPR frequencies at around 35 GHz and 80 GHz, respectively, were designed for the devices.

3. RESULTS AND DISCUSSIONS

For the implemented devices, InGaAsP multi-quantum well was used for the active layer. The waveguide
structure was a high mesa formed by using dry-etching.

![Magnified to Fig. 4](image)

**Fig. 3. Emission spectrum**

![Magnified to Fig. 4](image)

**Fig. 4. Emission spectrum**

![Magnified to Fig. 4](image)

**Fig. 5. Small signal response of the fabricated active-MMI LD**

Figure 3 shows the emission spectra of the implemented 1 × N active multimode interferometer laser diodes. DC currents were injected as follows: pumping region (MMI section): 172 mA, bias: 53 mA, lower arm: 57 mA, upper arm: 43 mA respectively. As shown in Fig. 4, two peaks beside the main peak were observed at 1564.65 nm and 1564.93 nm, respectively. The wavelength difference between main emission peaks are 0.20 nm and 0.48 nm, respectively. These wavelength differences are not exactly same with the designed ones, however, relatively agreeable. From eq. (3), FPPR appears at the positions of 25 GHz and 59 GHz from these wavelength differences. Figure 5 shows the evaluated small signal frequency response of the fabricated devices. As shown in the figure, the limitation of resonance frequency of LD (CPR peak) at 6 GHz, and two PPR peaks of 20 GHz and 60 GHz were clearly observed successfully. These PPR peaks were corresponding to the emission spectrum in Fig. 4, therefore, these two peaks are concluded that came from photon-photon resonances. In addition, the intensity of the second PPR at higher frequency of 60 GHz are high of more than 0 dB in the response, whereas the response between two peaks completely dropped down below -30 dB. Right now, the determination factors of PPR peak intensity are not so clear, however, we hope we may keep the frequency response flat at entire frequency band by introducing this effect.

<table>
<thead>
<tr>
<th>Monitored wavelength</th>
<th>PPR₁</th>
<th>PPR₂</th>
</tr>
</thead>
<tbody>
<tr>
<td>1564.65 nm</td>
<td></td>
<td></td>
</tr>
<tr>
<td>1564.93 nm</td>
<td></td>
<td></td>
</tr>
</tbody>
</table>

| Calculated Fₚₚᵣ     |      |      |
| 25 GHz               |      |      |
| 59 GHz               |      |      |

| Fₚₚᵣ in Fig. 3       |      |      |
| 20 GHz               |      |      |
| 60 GHz               |      |      |

4. CONCLUSION

Two PPRs of 20 GHz and 60 GHz based on 1 × N active-MMI LDs configuration was be able to successfully confirm. Presently, we still investigate the reason of the intensity recovery mechanism especially at high frequency. This approach of multiple PPRs is hoped that will realize flat frequency response up to very high frequency region of more than 100 GHz in the future.

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